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SHEET 1 OF 1

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)			ATTY. DOCKET NO. 073759-0016	SERIAL NO. 10/586,876		
			APPLICANT Yasuhito MASUDA, et al.			
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U.S. PATENT DOCUMENTS						
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ₂ (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		US				
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FOREIGN PATENT DOCUMENTS						
EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number + Kind Codes (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation Yes No
		JP 42-13560	08-01-1967	SUMITOMO ELECTRIC INDUSTRIES, LTD.		JAPAN (w/partial English translation)
		JP2002-160079	06-04-2002	LASER GIJUTSU SOGO KENKYUSHO; TOYO SEIMITSU KOGYO KK		JAPAN (w/English Abstract)
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)						
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				
		WADA, S., et al., "Direct photoetching of polymer films using vacuum ultraviolet radiation generated by high-order anti-Stokes Raman scattering.", APPL. PHYS. LETTER, January 18, 1993, pages 211-213, vol. 62 No. 3, American Institute of Physics.				
EXAMINER /Hai Vo/			DATE CONSIDERED 03/07/2008			

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